

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|------------------|
| L2 | 1340 | (wafer or substrate) near2 (optoelectronic or opto-electronic or optical\$3 near ready or optic\$4 near3 pre-fabricat\$4) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 08:56 |
| L3 | 70 | (wafer or substrate) near2 (optoelectronic or opto-electronic or optical\$3 near ready or optic\$4 near3 pre-fabricat\$4) and silicon and (optic\$4 or waveguid\$4) near6 (silica or bpsg or sio or silicon near oxide or silicon near dioxide or sin or sion or silicon near nitride or silicon near oxynitride) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 12:57 |
| L4 | 94 | (waveguid\$4 or wave-guid\$4 or optic\$4 near2 (circuit or network or signal or clock)) near8 (buried or burying or covered or underneath or covering or deposited or grown or growth or deposition) near6 (device or monocrystalline or monocrystal or single near crystal or crystalline or quality) near4 (si or silicon) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 10:54 |
| L5 | 337 | (waveguid\$4 or wave-guid\$4 or optic\$4 near2 (circuit or network or signal or clock)) near8 (buried or burying or covered or underneath or covering or deposited or grown or growth or deposition or over or above or upon or overlying or underlying or stacked or stack or stacking) near6 (mos or mosfet or cmos or nmos or pmos or transistor or electric\$4 near2 circuit\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 10:56 |
| L6 | 121 | (waveguid\$4 or wave-guid\$4 or optic\$4 near2 (clock)) near8 (buried or burying or covered or underneath or covering or deposited or grown or growth or deposition or over or above or upon or overlying or underlying or stacked or stack or stacking) near6 (mos or mosfet or cmos or nmos or pmos or transistor or electric\$4 near2 circuit\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 10:56 |
| L7 | 14 | ("4658402" "4727556" "4771010" "4788689" "4843032" "4857971" "4875216" "5179615" "5329601" "5521994" "5570439" "5574289" "5678935" "5682455").PN. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 11:51 |
| L8 | 0 | (optical near clock) near4 buried | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 11:51 |
| L9 | 197 | buried near4 waveguide same silicon | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 12:18 |
| L10 | 36 | buried near (oxide or sio or nitride or sin) near4 (waveguid\$4 or wave-guid\$4) | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 12:27 |
| L11 | 8 | "6658173".pn. "20020181825" "6680495".pn. "5418360".pn. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 12:18 |
| L12 | 472 | (optical or optic or photonic or light or waveguide) near3 (clock or clocking or timing) near4 (network or array or distribution) | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 12:28 |
| L13 | 128 | (optical or optic or photonic or light or waveguide) near3 (clock or clocking or timing) near4 (network or array or distribution) and silicon | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 12:34 |
| L14 | 412 | 438/31.cds. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 13:00 |
| L17 | 57 | (waveguid\$ or wave near guid\$4 or (optical or photonic or light) near2 (circuit\$3 or clock or network)) near5 (substrate) same (wafer or substrate) near4 (bonding or bonded or joined or fused or fusing or joining) same (electrical or microelectronic or electronic or mos or mosfet or transistor or nmos or pmos) near5 (substrate) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 13:03 |

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| L18 | 313 | 438/69.ccls. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 13:21 |
| L19 | 41 | (wafer or substrate) near4 (pre-fabricat\$4 or prefabricat\$4 or pre-process\$4) near10 (optical or optoelectronic or photonic or optic or waveguid\$4 or wave adj guid\$4) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 13:05 |
| L20 | 10 | (US-20020076130-\$ or US-20020167013-\$ or US-20030003738-\$ or US-20040017962-\$ or US-20030077060-\$ or US-20020181825-\$ or US-20030150376-\$).did. or (US-6936854-\$ or US-5917981-\$ or US-6658173-\$).did. | US-PGPUB; USPAT | OR | ON | 2006/01/19 13:17 |
| L21 | 3 | "5987196".pn. "20020146865" "5098861".pn. | US-PGPUB; USPAT | OR | ON | 2006/01/19 13:17 |
| L22 | 2686 | 385/14.ccls. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 13:34 |
| L23 | 128 | 385/14.ccls. and (waveguid\$4 or wave-guid\$4) near4 (silicon adj oxide or silicon adj dioxide or silicon adj oxynitride or silicon adj nitride or sio or sin or sion) | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 13:34 |
| L24 | 1805 | 385/31.ccls. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:01 |
| L25 | 30 | 385/31.ccls. and (waveguid\$4 or wave-guid\$4) near4 (silicon adj oxide or silicon adj dioxide or silicon adj oxynitride or silicon adj nitride or sio or sin or sion) | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:01 |
| L26 | 1602 | 385/129.ccls. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:24 |
| L27 | 137 | 385/129.ccls. and (waveguid\$4 or wave-guid\$4) near4 (silicon adj oxide or silicon adj dioxide or silicon adj oxynitride or silicon adj nitride or sio or sin or sion) | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:24 |
| L28 | 987 | 385/130.ccls. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:35 |
| L29 | 77 | 385/130.ccls. and (waveguid\$4 or wave-guid\$4) near4 (silicon adj oxide or silicon adj dioxide or silicon adj oxynitride or silicon adj nitride or sio or sin or sion) | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:35 |
| L30 | 911 | 385/131.ccls. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:53 |
| L31 | 63 | 385/131.ccls. and (waveguid\$4 or wave-guid\$4) near4 (silicon adj oxide or silicon adj dioxide or silicon adj oxynitride or silicon adj nitride or sio or sin or sion) | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:53 |
| L32 | 675 | 385/132.ccls. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:53 |
| L33 | 45 | 385/132.ccls. and (waveguid\$4 or wave-guid\$4) near4 (silicon adj oxide or silicon adj dioxide or silicon adj oxynitride or silicon adj nitride or sio or sin or sion) | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/19 14:58 |
| S2 | 820 | (waveguide or wave-guide or wave-guiding or optical near2 network or optical near2 distribution or optical near2 circuit) same (soi or silicon-on-insulator) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/19 08:55 |
| S3 | 181 | (waveguide or wave-guide or wave-guiding or optical near2 network or optical near2 distribution or optical near2 circuit) same (soi or silicon-on-insulator) near6 (mos or mosfet or transistor or circuitry or circuit or microelectronic or nmos or pmos or cmos) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/18 13:15 |

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|----|----|---|------------------------------|----|----|------------------|
| S4 | 17 | ("20010006567" "20020109074" "20020167013" "5191219" "5343542" "5357122" "5526449" "5593335" "5684817" "6139713" "6160347" "6231412" "6283815" "6310991" "6317554" "6466708" "6586775").PN. | US-PGPUB; USPAT; USOCR | OR | ON | 2006/01/18 17:11 |
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